



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

e the Application of

Teruo TAKIZAWA

Group Art Unit: 2826

Application No.: 10/785,073

Examiner:

K. QUINTO

Filed: February 25, 2004

Docket No.:

118439

SEMICONDUCTOR DEVICE AND METHOD

For:

OF MANUFACTURING THE SAME

MAIL STOP RCE

LARGE ENTITY REQUEST FOR **CONTINUED EXAMINATION UNDER 37 C.F.R. §1.114**

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

Sir:

In accordance with the provisions of 37 C.F.R. §1.114, Applicant hereby requests continued examination.

Applicant further requests entry and consideration of the attached submission.

The above-identified application was filed on or after June 8, 1995. Thus, entry is proper under 37 C.F.R. §1.114(d).

Attached hereto is our check no. 168301 in the amount of X \$790.00 as payment of the fees set forth in 37 C.F.R. §1.17(e). The Commissioner is hereby authorized to charge any additional fees or credit any overpayment associated with this communication to Deposit Account No. 15-0461. Two duplicate copies of this page are enclosed.

tfully submitted,

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Registration No. 27,075

790.00 OP

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Richard S. Elias

Registration No. 48,806

JAO:RSE/eks

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Date: June 30, 2005

OLIFF & BERRIDGE, PLC P.O. Box 19928 Alexandria, Virginia 22320 Telephone: (703) 836-6400

DEPOSIT ACCOUNT USE **AUTHORIZATION** Please grant any extension necessary for entry; Charge any fee due to our Deposit Account No. 15-0461